Particle Transport, Deposition and Removal

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Particle Adhesion and Detachment Models

Goodarz Ahmadi

Department of Mechanical and Aeronautical Engineering
Clarkson University
Potsdam, NY 13699-5725

Outline

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- Particle Detachment Mechanisms
- JKR Adhesion Model
- DMT Adhesion Model
- Maugis-Pollock Model
- Maximum Moment Resistance

Particle Adhesion and Detachment Models

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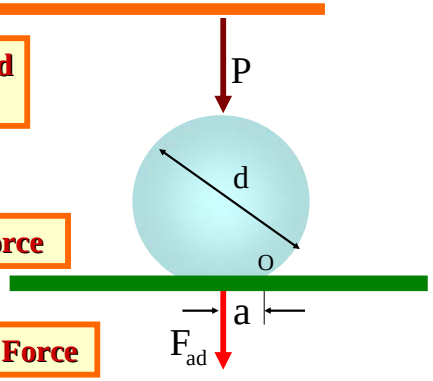
Sphere Attached to a Surface

a = Contact

P = Exerted Force

F_{ad} = Adhesion Force



JKR Model

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Johnson-Kandall-Roberts (1971)

$$a^3 = \frac{d}{2K}\left[P + \frac{3}{2}W_A \pi d + \sqrt{3\pi W_A dP + \left(\frac{3\pi W_A d}{2}\right)^2}\right]$$

$$K = \frac{4}{3}\left[\frac{1-\upsilon_1^2}{E_1} + \frac{1-\upsilon_2^2}{E_2}\right]^{-1}$$

Hertz Model

$$a^3 = \frac{dP}{2K}$$

JKR Model

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Pull-Off Force

$$F_{po}^{JKR} = \frac{3}{4}\pi W_A d$$

Contact Radius at Zero Force

$$a_0 = \left(\frac{3\pi W_A d^2}{2K}\right)^{\frac{1}{3}}$$

Contact Radius at Separation

$$a = \left(\frac{3\pi W_A d^2}{8K}\right)^{\frac{1}{3}} = \frac{a_0}{4^{1/3}}$$

DMT Model

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Derjaguin-Muller-Toporov (1975)

Pull-Off Force

$$F_{Po}^{DMT} = \pi W_A d$$

$$F_{Po}^{DMT} = \frac{4}{3}F_{Po}^{JKR}$$

Contact Radius at Zero Force

$$a_0 = \left(\frac{\pi W_A d^2}{2K}\right)^{\frac{1}{3}}$$

Contact Radius at Separation

$$a = 0$$

Maugis-Pollock Model

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$$P + \pi W_A d = \pi a^2 H$$

$$H = 3Y$$

$$a_0 \sim d^{\frac{2}{3}} \quad \text{Elastic}$$

$$a_0 \sim d^{\frac{1}{2}} \quad \text{Plastic}$$

Examples of Adhesion-Induced Deformations - JKR Systems

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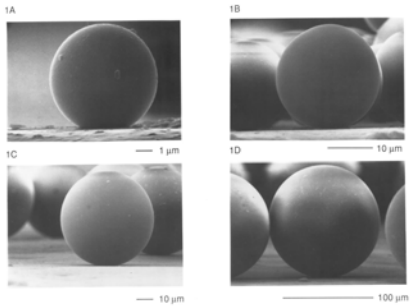
Rimai et al.

Polystyrene on Polyurethane

High elastic modulus spherical particles on elastomeric substrates.



Examples of Adhesion-Induced Deformations - JKR Systems

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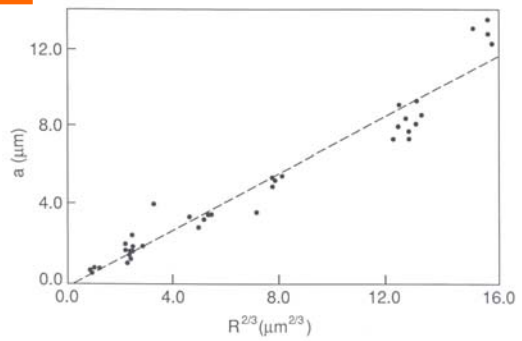
Rimai et al.

GLASS BEADS ON POLYURETHANE SUBSTRATE



Non-JKR Systems

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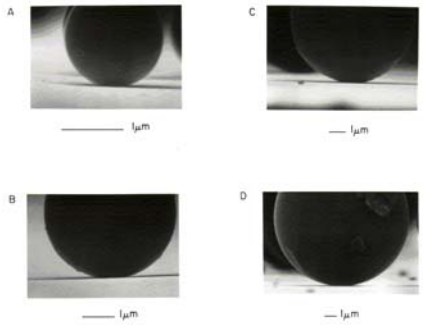
Rimai et al.

Polystyrene particles on a silicon wafer



Non-JKR Systems

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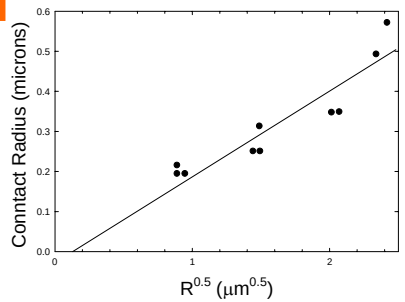
Rimai et al.



Thermodynamic Work of Adhesion

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$$W_A = \frac{A}{12\pi z_0^2}$$

JKR Model

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$$a^{*3} = 1 - P^* + \sqrt{1 - 2P^*}$$

$$P^* = -\frac{P}{\frac{3}{2}\pi W_A d} \qquad a^* = \frac{a}{\left(\frac{3\pi W_A d^2}{4K}\right)^{\frac{1}{3}}}$$

$$a_0^* = 1.26$$

JKR Model

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$$M^{*JKR} = P^* a^* = P^*(1 - P^* + \sqrt{1 - 2P^*})^{1/3}$$

Maximum Moment → $M_{max}^{*JKR} = 0.42$

$$P_{max}^* = F_{po}^{*JKR} = \frac{F^{JKR}}{\frac{3\pi}{2} W_A d} = 0.5$$ → $M^{*JKR} = 0.397$

$P_{max}^* a_0^* = 0.63$

DMT Model

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Contact Radius → $a^3 \approx \frac{d}{2K}(P + \pi W_A d)$

Nondimensional Contact Radius → $a^{*3} = \left(\frac{a}{3\pi W_A d^2 / 4K}\right)^3 = -P^* + \frac{2}{3}$

Resistance Moment → $M^{*DMT} = P^*(2/3 - P^*)^{1/3}$

Maximum Moment → $M_{max}^{*DMT} = 0.28$

JKR-DMT Models

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$$P_{max}^* = F_{po}^{*DMT} = \frac{F^{DMT}}{\frac{3\pi}{2} W_A d} = \frac{2}{3}$$

$P_{max}^* a_0^* = 0.58$

$M^{*DMT} = 0$

Maximum Moments → $M_{max}^{*JKR} = 0.42 = 1.5 M_{max}^{*DMT}$

$$M_{max}^{JKR} = 2.63 \frac{W_A^{\frac{4}{3}} d^{\frac{5}{3}}}{\kappa^{\frac{1}{3}}}$$

$$M_{max}^{DMT} = 1.83 \frac{W_A^{\frac{4}{3}} d^{\frac{5}{3}}}{\kappa^{\frac{1}{3}}}$$

JKR-DMT Models

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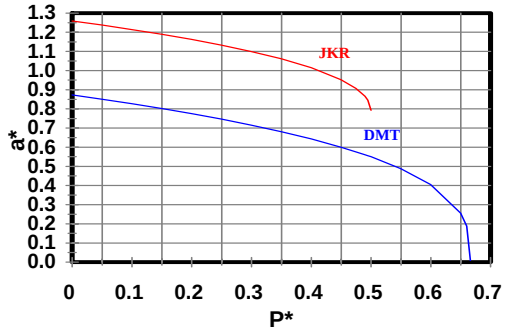

Variations of contact radius with the exerted force.

JKR-DMT Models

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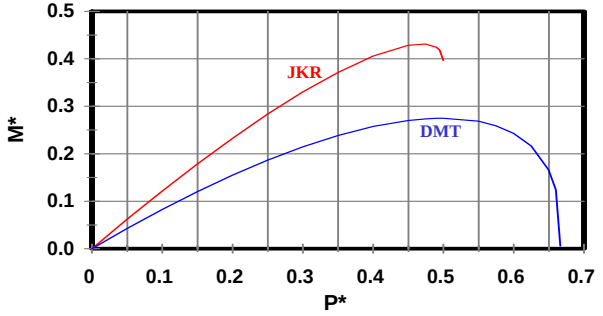

Variations of resistance moment with the exerted force.

Conclusions

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- Spherical particles are removed by overcoming the adhesion rolling resistance
- JKR, DMT and Maugis-Pollock Models
- Contact radius varies differently with d for elastic and plastic deformations

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Thank you!

Questions?